



an Open Access Journal by MDPI

Smart Sensors 2020

Guest Editors:

Dr. Cheng-Hsin Chuang

Institute of Medical Science and
Technology, National Sun Yat-
sen University, Kaohsiung 80424,
Taiwan

Prof. Yi Chiu

Department of Electrical and
Computer Engineering, National
Chiao Tung University, Hsin Chu,
Taiwan

Deadline for manuscript
submissions:

closed (30 April 2021)

Message from the Guest Editors

Dear Colleagues,

The 2020 International Conference on Smart Sensors (ICSS) will be held on 22–23 June 2020 at National Sun Yat-sen University, Kaohsiung, Taiwan. As with last year, the conference is a joint event of the 25th Symposium of Association for Chemical Sensors in Taiwan and the 23rd Nano Engineering and Microsystem Technology Conference.

This Special Issue will publish both selected papers from ICSS 2020 and external papers. The topics to be covered include but are not limited to:

- Chemical Sensors
- Biosensors
- Microfluidics for Medical Applications
- MEMS and NEMS Fabrication
- Microfluidics
- Applied MEMS and Applied Microfluidics

We encourage both original research papers and comprehensive review articles to be submitted to this Special Issue.



mdpi.com/si/42185

Special Issue



an Open Access Journal by MDPI

Editor-in-Chief

Prof. Dr. Ai-Qun Liu

1. Department of Electrical and Electronic Engineering, The Hong Kong Polytechnic University, Hong Kong, China
2. School of Electrical and Electronic Engineering, Nanyang Technological University, Singapore 639798, Singapore

Message from the Editor-in-Chief

You are invited to contribute research articles or comprehensive reviews for consideration and publication in *Micromachines* (ISSN 2072-666X). *Micromachines* is published in the open access format. Research articles, reviews and other contents are released on the internet immediately after acceptance. The scientific community and the general public have unlimited free access to the content as soon as it is published. As an open access journal, *Micromachines* is supported by the authors or their institutes by payment of article processing charges (APC) for accepted papers. We are pleased to welcome you as our authors.

Author Benefits

Open Access: free for readers, with article processing charges (APC) paid by authors or their institutions.

High Visibility: indexed within Scopus, SCIE (Web of Science), PubMed, PMC, Ei Compendex, dblp, and other databases.

Journal Rank: JCR - Q2 (*Physics, Applied*) / CiteScore - Q2 (*Mechanical Engineering*)

Contact Us

Micromachines Editorial Office
MDPI, Grosspeteranlage 5
4052 Basel, Switzerland

Tel: +41 61 683 77 34
www.mdpi.com

mdpi.com/journal/micromachines
micromachines@mdpi.com
[X@micromach_mdpi](https://twitter.com/micromach_mdpi)